

AUG 27 2007

Docket No. 740756-2100

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Confirmation No.: 6768
Hongyong Zhang	)	
Serial No. 09/633,869	)	Examiner: Alexander G. Ghyka
Filed: August 7, 2000	)	Group Art Unit: 2812
For: <b>METHOD FOR LASER- PROCESSING SEMICONDUCTOR DEVICE</b>	)	Date: August 27, 2007

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Non-Final Office Action mailed April 27, 2007, please amend the above-captioned application, as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks** follow the amendment section of this paper.

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